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Attorney's Docket No.: 3558P020D2

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)

James M. Cleeves et al.)

U.S. Serial No: 10/800,078)

Examiner: Ngo, Ngan V.)

Filed: March 12, 2004)

Art Unit: 2814)

For: INTEGRATED CIRCUIT)

FEATURE LAYOUT FOR IMPROVED)

CHEMICAL MECHANICAL POLISHING)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed September 28, 2004. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP _____

COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450

U.S. Patent and Trademark Office, Washington, D.C. 20231 on December 7, 2004
Date of Deposit

Teresa Mattox

Name of Person Mailing Correspondence

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Signature

December 7, 2004

Date